What is claimed is:

- 1 1. An electronic package having one or more components
- 2 comprising:
- 3 a substrate having a first coefficient of thermal
- 4 expansion;
- 5 a lid attached to said substrate, said lid including a
- 6 vapor chamber, the lid having a second coefficient of
- 7 thermal expansion, said first coefficient of thermal
- 8 expansion matched to said second coefficient of expansion;
- 9 a thermal transfer medium in contact with a back
- 10 surface of each component and an outer surface of a lower
- 11 wall of said lid; and
- each component electrically connected to a top surface
- 13 of said substrate.
 - 1 2. The electronic package of claim 1, wherein said lower
 - 2 wall of said lid has a third coefficient of thermal
 - 3 expansion and said components have a fourth coefficient of
 - 4 expansion, said third coefficient of expansion matched to
 - 5 said fourth coefficient of expansion.

- 1 3. The electronic package of claim 1, further including a
- 2 heat sink having a fifth coefficient of thermal expansion
- 3 mounted to an outer surface of a top wall of said lid, said
- 4 fifth coefficient of expansion matched to said second
- 5 coefficient of expansion.
- 1 4. The electronic package of claim 1, wherein said lower
- 2 wall of said lid has protruding regions for maintaining
- 3 equivalent contact with said thermal transfer medium on thin
- 4 components of said components as is maintained by thin
- 5 regions on thick components of said components.
- 1 5. The electronic package of claim 1, further including
- 2 supports within said vapor chamber between an upper wall of
- 3 said vapor chamber and said lower wall, some or all of said
- 4 supports aligned over some or all of said components.
- 1 6. The electronic package of claim 5, wherein said supports
- 2 are integrally formed with said lid.
- 1 7. The electronic package of claim 1, wherein said package
- 2 is selected from the group consisting of ball grid array

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- 3 modules, pin grid array modules, land grid array modules and
- 4 HyperBGA™ modules.
- 1 8. The electronic package of claim 1, wherein said lid is
- 2 formed from material selected from the group consisting of
- 3 aluminum, copper, Invar, gold, silver, nickel, aluminum-
- 4 silicon carbide, plastics, ceramics and composites.
- 1 9. The electronic package of claim 1, wherein said substrate
- 2 includes material selected from the group consisting of
- 3 ceramics, fiberglass, polytetraflouroethylene, and polymers.

- 1 10. A method for dissipating heat from an electronic package
- 2 having one or more components comprising:
- 3 providing a substrate having a first coefficient of
- 4 thermal expansion;
- 5 attaching a lid to said substrate, said lid including a
- 6 vapor chamber, the lid having a second coefficient of
- 7 thermal expansion;
- 8 matching said first coefficient of thermal expansion
- 9 matched to said second coefficient of expansion;
- 10 providing a thermal transfer medium in contact with a
- 11 back surface of each component and an outer surface of a
- 12 lower wall of said lid; and
- 13 electrically connecting each component to a top surface
- 14 of said substrate.
- 1 11. The method of claim 10, wherein said lower wall of said
- 2 lid has a third coefficient of thermal expansion and said
- 3 components have a fourth coefficient of expansion and
- 4 further including matching said third coefficient of
- 5 expansion to said fourth coefficient of expansion.
- 1 12. The method of claim 10, further including:

- 2 mounting a heat sink having a fifth coefficient of
- 3 thermal expansion to an outer surface of a top wall of said
- 4 lid, and
- 5 matching said fifth coefficient of expansion to said
- 6 second coefficient of expansion.
- 1 13. The method of claim 10, wherein said lower wall of said
- 2 lid has protruding regions for maintaining equivalent
- 3 contact with said thermal transfer medium on thin components
- 4 of said components as is maintained by thin regions on thick
- 5 components of said components.
- 1 14. The method of claim 10, further including providing
- 2 supports within said vapor chamber between an upper wall of
- 3 said vapor chamber and said lower wall, some or all of said
- 4 supports aligned over some or all of said components.
- 1 15. The method of claim 10, wherein said package is selected
- 2 from the group consisting of ball grid array modules, pin
- 3 grid array modules, land grid array modules and HyperBGATM
- 4 modules.

- 1 16. The method of claim 1, wherein said lid is formed from
- 2 material selected from the group consisting of aluminum,
- 3 copper, Invar, gold, silver, nickel, aluminum-silicon
- 4 carbide, plastics, ceramics and composites.
- 1 17. The method of claim 10, wherein said substrate includes
- 2 material selected from the group consisting of ceramics,
- 3 fiberglass, polytetraflouroethylene, and polymers.

- 1 18. An electronic package having one or more components
- 2 comprising:
- 3 a substrate having a first coefficient of thermal
- 4 expansion;
- 5 a lid attached to said substrate, said lid including a
- 6 vapor chamber, the lid having a second coefficient of
- 7 thermal expansion, said first coefficient of thermal
- 8 expansion between about 25% to about 700% of said second
- 9 coefficient of expansion;
- 10 a thermal transfer medium in contact with a back
- 11 surface of each component and an outer surface of a lower
- 12 wall of said lid; and
- 13 each component electrically connected to a top surface
- 14 of said substrate.
- 1 19. The electronic package of claim 18, wherein said lower
- 2 wall of said lid has a third coefficient of thermal
- 3 expansion and said components have a fourth coefficient of
- 4 expansion, said third coefficient of thermal expansion
- 5 between about 50% to about 700% of said fourth coefficient
- 6 of expansion.

- 1 20. The electronic package of claim 18, further including a
- 2 heat sink having a fifth coefficient of thermal expansion
- 3 mounted to an outer surface of a top wall of said lid, said
- 4 fifth coefficient of expansion between about 25% to about
- 5 700% of said first coefficient of expansion.